



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 21, 2026

IGI Report Number **LG768604650**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.07 - 8.12 X 5.12 MM**

GRADING RESULTS

Carat Weight **2.09 CARATS**

Color Grade **F**

Clarity Grade **VS 2**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

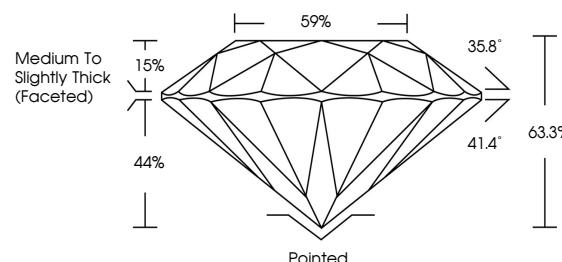
IGI **LG768604650**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

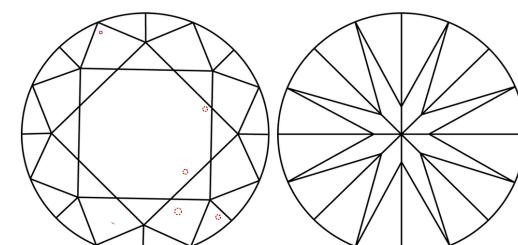
Type Ila

LG768604650
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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VS 2

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Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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ADDITIONAL GRADING INFORMATION

EXCELLENT

Polish **Symmetry**

NONE

Fluorescence **Inscription(s)**

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